
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(219.005-US-C1)

In re Application of: **YAMADA ET AL.**

Serial No: **CONTINUATION OF 10/082,247**

U.S. Filing Date: **FEBRUARY 27, 2004**

Title: **PRODUCTION MANAGING SYSTEM
OF SEMICONDUCTOR DEVICE**

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) Group Art Unit:
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) Examiner:
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Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FIRST PRELIMINARY AMENDMENT

Dear Sir:

Preliminary to the examination of the above-referenced application, kindly amend the application as follows: